

## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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### Title of Invention

METHOD OF FABRICATING POLY-CRYSTAL ITO FILM AND  
POLYCRYSTAL ITO ELECTRODE

Application Number :

10/711 864

Confirmation Number:

10/11/04

First Named Applicant:

Fang-An Shu

Attorney Docket Number:

14150-US-PA

Art Unit:

Examiner:

Search string:

( 6448158 or 6218310 ).pn

### US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
TN	1	6448158	2002-09-10	Chih-Yu Peng	B2	438	487
TN	2	6218310	2001-04-17	Lewis Shen	B1	438	714

### Signature

Examiner Name	Date
	9/14/05